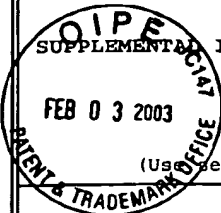


PTO-1449 REPRODUCED		ATTORNEY DOCKET NO. 0717.2022-000		APPLICATION NO. 10/022,190				
<div style="text-align: center;">  <p>SUPPLEMENTAL INFORMATION DISCLOSURE CITATION IN AN APPLICATION</p> <p>January 29, 2003</p> <p>(Use several sheets if necessary)</p> </div>		APPLICANT Matthew Zavracky, et al.						
		FILING DATE December 17, 2001		CONFIRMATION NO. 1518	GROUP 2871			
U.S. PATENT DOCUMENTS								
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✓ <i>RL</i>	AC2	5,422,751	06/06/1995	Lewis, et al.				
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		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION YES NO	
✓ <i>RL</i>	AM	DE 3408176 A1	19-SEP-1985	Germany				X
✓ <i>RL</i>	AN	JP 03189618	19-AUG-1991	Japan (Abstract)				
✓ <i>RL</i>	AO	JP 05165015	29-JUN-1993	Japan (Abstract)				
✓ <i>RL</i>	AP	JP 06258637	16-SEP-1994	Japan				X
✓ <i>RL</i>	AQ	JP 07225375	22-AUG-1995	Japan (Abstract)				
✓ <i>RL</i>	AL2	WO 98/19435	07-MAY-1998	PCT				
✓ <i>RL</i>	AM2	WO 99/23636	14-MAY-1999	PCT				
✓ <i>RL</i>	AN2	JP 2000075289	14-MAR-2000	Japan (Abstract)				
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)								
	AR							
	AS							
	AT							
EXAMINER				DATE CONSIDERED				
